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April 12, 2007

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Re: Applicants: Chunyuan Chao, Kuei-Chang Tsai and George A. Kovall  
Assignee: Mosel Vitelic, Inc.  
Title: Dynamically Controllable Reduction Of Vertical Contact Diameter Through Adjustment Of Etch Mask Stack For Dielectric Etch  
Application No.: 10/718,320 Filed: November 19, 2003  
Examiner: Deo, Duy Vu Nguyen Group Art: 1765  
Docket No.: M-15208 US Confirmation No.: 1058

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter (1 page in duplicate); and
- (3) Amendment (10 pages).



No additional fee is required.



The fee has been calculated as shown below:

## CLAIMS AS AMENDED

	Claims Remaining After Amendment		Highest No. Previously Paid For		Present Extra	Rate	Additional Fee
Total Claims	34	Minus	37	=	0	x \$50.00	\$ 0.00
Independent Claims	3	Minus	4	=	0	x \$200.00	\$ 0.00
<input type="checkbox"/> Fee for Request for Extension of Time							\$ 0.00

### Total additional fee for this Amendment:

\$



Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.



Please charge our Deposit Account No. 50-2257 in the amount of

\$

0.00



Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 50-2257

Total:

\$

0.00



Correspondence Address: Address Associated with Customer Number: 32605

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 12, 2007.

4-12-2007

Attorney for Applicant(s)

Date of Signature

Respectfully submitted,

Gideon Gimlan  
Attorney for Applicants  
Reg. No. 31,955

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant(s): Chunyuan ("Luis") Chao et al  
Assignee: Mosel-Vitellic, Inc.  
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San Jose, California  
April 12, 2007

MailStop: Amendment

**COMMISSIONER FOR PATENTS**  
**P.O. BOX 1450**  
**ALEXANDRIA, VA 22313-1450**

**AMENDMENT**

Dear Sir:

In response to the Office Action having a mailing date of January 17, 2007, please  
amend the application as set forth below.

**Claims Listing** begins on page 2 of this paper.

**Remarks** begin on page 9 of this paper.

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